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# UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): James E. Moon et al.

Serial No.: 10/003,851

Art Unit: 1746

Filed: November 02, 2001

Examiner: Not Yet Assigned

Title: **METHOD FOR FABRICATING MEMS AND MICROFLUIDIC DEVICES  
USING SMILE, LATENT MASKING, AND DELAYED LOCOS TECHNIQUES**

Assistant Commissioner for Patents  
Washington, DC 20231

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## AMENDMENT

On Page 1 of the specification, please amend the title of the patent application identified  
above to METHOD FOR FABRICATING MEMS AND MICROFLUIDIC DEVICES USING  
SMILE, LATENT MASKING, AND DELAYED LOCOS TECHNIQUES.

This amendment is submitted to render the title of the invention consistent with the title  
submitted by Applicants on Applicants' transmittal papers accompanying the application as filed.

April 18, 2003

Date

Respectfully submitted,

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